



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov

BIB DATA SHEET

CONFIRMATION NO. 3685

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.	
10/578,683	05/09/2006	430	1795	05823.0283	
RULE					
APPLICANTS Hai Won Lee, Kyunggi-do, KOREA, REPUBLIC OF; Sun Woo Lee, Seoul, KOREA, REPUBLIC OF; Jin ho Ahn, Seoul, KOREA, REPUBLIC OF; Suk Jong Bae, Seoul, KOREA, REPUBLIC OF;					
** CONTINUING DATA ***** This application is a 371 of PCT/KR04/01363 06/08/2004					
** FOREIGN APPLICATIONS ***** REPUBLIC OF KOREA 10-2003-0082777 11/20/2003					
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** ** SMALL ENTITY ** 11/22/2006					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and <u>/STEPHEN D</u> Acknowledged <u>ROSASCO/</u> Examiner's signature	<input type="checkbox"/> Met after Allowance <u>Initials</u>	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWINGS 5	TOTAL CLAIMS 3	INDEPENDENT CLAIMS 1
ADDRESS FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER LLP 901 NEW YORK AVENUE, NW WASHINGTON, DC 20001-4413 UNITED STATES					
TITLE Fabrication method of extreme ultraviolet radiation mask mirror using atomic force microscope lithography					
FILING FEE RECEIVED 450	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	